

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

DORDI et al.

Application No: 10/735,216

Filed: December 12, 2003

For: METHOD AND APPARATUS FOR
MATERIAL DEPOSITION IN
SEMICONDUCTOR FABRICATION



Docket No: LAM2P458

Group Art Unit: 2813

Examiner: Nguyen, Thanh T.

Date: October 23, 2006

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 on October 23, 2006.

Signed: _____

Kenneth D. Wright

Mail Stop: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.
The fee has been calculated as shown below.

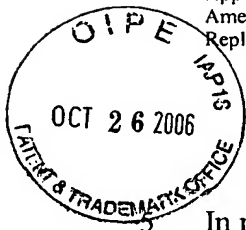
	Remaining After Amendment	Highest Previously Paid For	Present Extra	SMALL ENTITY RATE FEE	OR	LARGE ENTITY RATE FEE
TOTAL CLAIMS	27 -	52	0	X25 = \$	OR	X50 = \$
INDEP CLAIMS	4 -	6	0	X100 = \$	OR	X200 = \$
			TOTAL	\$ _____		\$ _____

- ☐ Applicant(s) hereby petition for a _____ month(s) extension of time to respond to the outstanding Office Action.
- ☒ Applicant(s) believe that no Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805 (Order No. LAM2P458).
- ☐ Enclosed is our Check No. _____ in the amount of \$ _____ to cover the additional claim fee and/or extension of time fees.
- ☒ If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM2P458). A copy of this sheet is enclosed.

Respectfully submitted,
MARTINE PENILLA & GENCARELLA, LLP

Kenneth D. Wright
Registration No. 53,795

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PATENT

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Signed: _____

Kenneth D. Wright

AMENDMENT

Mail Stop: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Amendment is submitted in reply to the Office Action dated July 25, 2006, and within the three-month period for reply extending to October 25, 2006. Please enter the following remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this Amendment.

Remarks/Arguments begin on page 9 of this Amendment.